INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 20, 2026

IGI Report Number	LG819644337
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	8.50 X 6.19 X 4.07 MM

GRADING RESULTS

Carat Weight	2.01 CARATS
Color Grade	H
Clarity Grade	VVS 2
Cut Grade	EXCELLENT

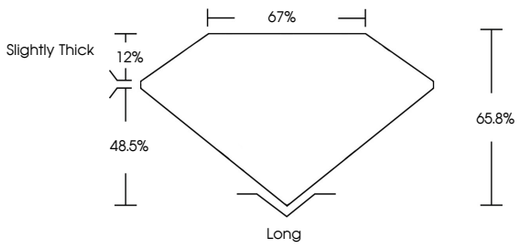
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	LG819644337

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG819644337
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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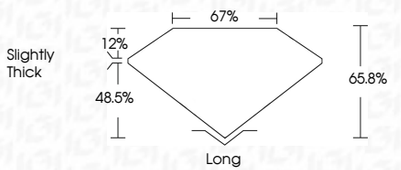
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www.igi.org

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EMERALD CUT
8.50 X 6.19 X 4.07 MM
Carat Weight 2.01 CARATS
Color Grade H
Clarity Grade VVS 2
Cut Grade EXCELLENT
Depth 65.8%
Table 67%
Girdle Slightly Thick
Culet Long
Polish EXCELLENT
Symmetry VERY GOOD
Fluorescence NONE
Inscription(s) LG819644337
Comments:
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Type IIa